

**Amendments to the Specification:**

Please amend the specification as follows:

Please replace the Title of the Invention from the PCT Application with the following new title:

METHOD OF CLEANING SUBSTRATE PROCESSING APPARATUS.

Please replace the paragraph on page 7, lines 26-27, with the following replacement paragraph:

~~Fig. 1 is a diagram Figs 1A and 1B are diagrams showing an outline of a plasma processing apparatus.~~